

Substitute for Form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known		
				Application Number	10/772,893	
				Filing Date	02/04/2004	
				First Named Inventor:	Pravin K. Narwankar	
				Art Unit	2812	
				Examiner Name	Not yet assigned	
				Attorney Docket Number	008209/USA/FEP/GCM/RKK	
Sheet 1 of 1						
U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
/KMS/		us-	2002/0073925 A1	06-20-2002	David Noble, et al.	
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NON PATENT LITERATURE DOCUMENTS			
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/KMS/		Bensahel, D, et al. " Front-end, single wafer diffusion processing for advanced 300-mm fabrication lines." Microelectronics Engineering, Elsevier Publishers BV., Amsterdam, NL, vol. 56, no. 1-2, May 2001, Pages 4-59.	
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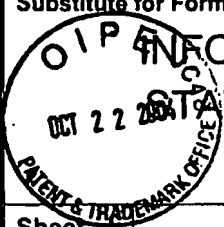
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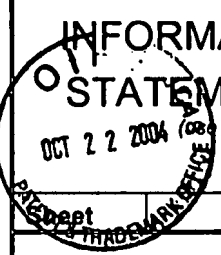
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/KMS/	1	US	6,323,143 B1	11-27-2001	Yu, Mo-Chiun	
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/KMS/	8	PCT Search Report, PCT/US2004/003442, mailed August 25, 2004, (6 pages).			

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/KMS/		ITO, T., et al., "Direct Thermal Nitridation of Silicon Dioxide Films In Anhydrous Ammonia Gas," J. Electrochem Soc.: Solid-State and Technology/Optical Properties, Vol. 127, No. 9, September 1980, pages 2053-2057,	
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